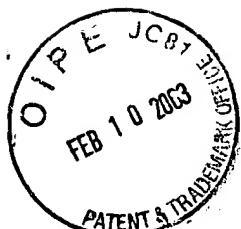




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<b>Substitute for form 1449A/PTO</b>  <b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b>  (use as many sheets as necessary)		<b>Complete if Known</b>			
		Application Number	09/916,023		
		Filing Date	07-26-2001		
		First Named Inventor	Christopher C. Hobbs et al.		
		Group Art Unit	2823		
Sheet	2	of	2	Examiner Name	Fernando Toledo
				Attorney Docket Number	SC11714TP

**OTHER PRIOR ART - NON PATENT LITERATURE DOCUMENTS**

Examiner Initials*	Cite No. 1	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T <sup>2</sup>
HL	BK	ANONYMOUS, "Method for Etching of Hafnium and Zirconium Oxide Metal Layers," Research Disclosure, 06-01-1989, Pg. 401, No. 302, Kenneth Mason Publications, Hampshire, GB.	
HL	BL	YUE KUO, "Anomalous High Rate Reactive Ion Etching Process for Indium Tin Oxide," Japanese Journal of Applied Physics, 05-15-1997, Pgs L629-L631, Vol. 36 No. 5B, Publication Office Japanese Journal of Applied Physics, Tokyo.	
HL	BM	T. KANNIAINEN et al., "Growth of Dielectric HfO <sub>2</sub> /TA <sub>2</sub> O <sub>5</sub> Thin Film Nanolaminate Capacitors by Atomic Layer Epitaxy," Electrochemical Society Proceedings, 08-31-1997, Pgs. 36-46, Vol. 97-31, Electrochemical Society, New Jersey.	

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Examiner Signature	<i>Fernando Toledo</i>	Date Considered	9/5/03
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EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation, if not in conformance and not considered. Include copy of this form with next communication to applicant.

<sup>1</sup> Unique citation designation number. <sup>2</sup> Applicant is to place a check mark here if English Language Translation is attached.